

Transaction Information

ToolId	MEM100
ToolStatus	Connected
Location	Dresden
WaferSize	300 mm
FabSection	Metrology

General Product Information

VendorSupplier	Semilab
Model	IR3100S
Vintage	2014
SerialNo	4010
AssetDescription	
SoftwareVersion	
CIM	SECS, GEM
Process	Dielectric characterization

Hardware Configuration (Fab)

SystemType	Description	Quantity	Status
Main System	Microspot Spectroscopic Ellipsometer (uSE) and small spot Model-Based Infrared Reflectometry (MBIR)	1	OK
Factory Interface	FOUP	2	OK
Handler System	Brooks Robot	1	OK
Options System			OK
Others			OK

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
NONE		OK

Missing/Faulty Parts / Accesories List

Description	Quantity
NONE	

Tool Pictures

general	MEM100
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general	MEM100
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general	MEM100
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general

MEM100



manufactureserial

Serial tag



Additional Configuration Files